



Corres. and Mail  
**BOX AF**

MAIL STOP AF  
RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2100

AFS  
MM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. Granik et al.

Attorney Docket No.: MEGC117332

Application No.: 09/898,431

Group Art Unit: 2123 / Confirmation No. 1914

Filed: July 2, 2001

Examiner: T.H. Stevens

Title: METHOD OF COMPENSATING FOR ETCH EFFECTS IN  
PHOTOLITHOGRAPHIC PROCESSING

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116/

PETITION FOR EXTENSION OF TIME

Seattle, Washington 98101

December 2, 2005

TO THE COMMISSIONER FOR PATENTS:

INTRODUCTORY COMMENTS

Please amend the above-identified application as follows.

12/06/2005 DTESEM1 00000062 09898431

01 FC:1251

120.00 OP

LAW OFFICES OF  
CHRISTENSEN O'CONNOR JOHNSON KINDNESS<sup>PLC</sup>  
1420 Fifth Avenue  
Suite 2800  
Seattle, Washington 98101  
206.682.8100